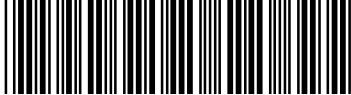


Application Number 	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/723,037 Examiner Jinhee J. Lee	KLIER, JAN Art Unit 2174